



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al. Art Unit : 2814
Serial No. : 09/903,339 Examiner : Theresa T. Doan
Filed : July 10, 2001
Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM
SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF NOVEMBER 3, 2004

Please amend the above-identified application as follows:

Amendments to the Claims begin on page 2.

Remarks begin on page 4.